



# Actuation and Response in Microsystems

**Prof. Mark Rodwell**

Electrical and Computer  
Engineering Department and  
Director of Nanofabrication Laboratory,  
University of California, Santa Barbara

The views and opinions presented by the invited speakers are their own  
and should not be interpreted as representing the official views of DARPA or DoD

Approved For Public Release, Distribution Unlimited

Report Documentation Page				Form Approved OMB No. 0704-0188	
Public reporting burden for the collection of information is estimated to average 1 hour per response, including the time for reviewing instructions, searching existing data sources, gathering and maintaining the data needed, and completing and reviewing the collection of information. Send comments regarding this burden estimate or any other aspect of this collection of information, including suggestions for reducing this burden, to Washington Headquarters Services, Directorate for Information Operations and Reports, 1215 Jefferson Davis Highway, Suite 1204, Arlington VA 22202-4302. Respondents should be aware that notwithstanding any other provision of law, no person shall be subject to a penalty for failing to comply with a collection of information if it does not display a currently valid OMB control number.					
1. REPORT DATE <b>MAR 2009</b>		2. REPORT TYPE		3. DATES COVERED <b>00-00-2009 to 00-00-2009</b>	
4. TITLE AND SUBTITLE <b>THz and nm Transistors for 1-1000 GHz Electronics</b>				5a. CONTRACT NUMBER	
				5b. GRANT NUMBER	
				5c. PROGRAM ELEMENT NUMBER	
6. AUTHOR(S)				5d. PROJECT NUMBER	
				5e. TASK NUMBER	
				5f. WORK UNIT NUMBER	
7. PERFORMING ORGANIZATION NAME(S) AND ADDRESS(ES) <b>University of California, Santa Barbara,Electrical and Computer Engineering Department,Santa Barbara,CA,93106</b>				8. PERFORMING ORGANIZATION REPORT NUMBER	
9. SPONSORING/MONITORING AGENCY NAME(S) AND ADDRESS(ES)				10. SPONSOR/MONITOR'S ACRONYM(S)	
				11. SPONSOR/MONITOR'S REPORT NUMBER(S)	
12. DISTRIBUTION/AVAILABILITY STATEMENT <b>Approved for public release; distribution unlimited</b>					
13. SUPPLEMENTARY NOTES <b>MTO (DARPA Microsystems Technology Office) Symposium, 2009, Mar 2-5, San Jose, CA. U.S. Government or Federal Rights License</b>					
14. ABSTRACT					
15. SUBJECT TERMS					
16. SECURITY CLASSIFICATION OF:			17. LIMITATION OF ABSTRACT <b>Same as Report (SAR)</b>	18. NUMBER OF PAGES <b>27</b>	19a. NAME OF RESPONSIBLE PERSON
a. REPORT <b>unclassified</b>	b. ABSTRACT <b>unclassified</b>	c. THIS PAGE <b>unclassified</b>			

# ***THz and nm Transistors for 1-1000 GHz Electronics***

*Mark Rodwell*  
***University of California, Santa Barbara***

# The End (of Moore's Law) is Near (?)

---

*It's a great time to be working on electronics !*

*Things to work on:*

*InP transistors: extend to 3-4 THz → GHz & low-THz ICs*

*GaN HEMTs: powerful transmitters from 1-300 GHz*

*Si MOSFETs: scale them past 16 nm*

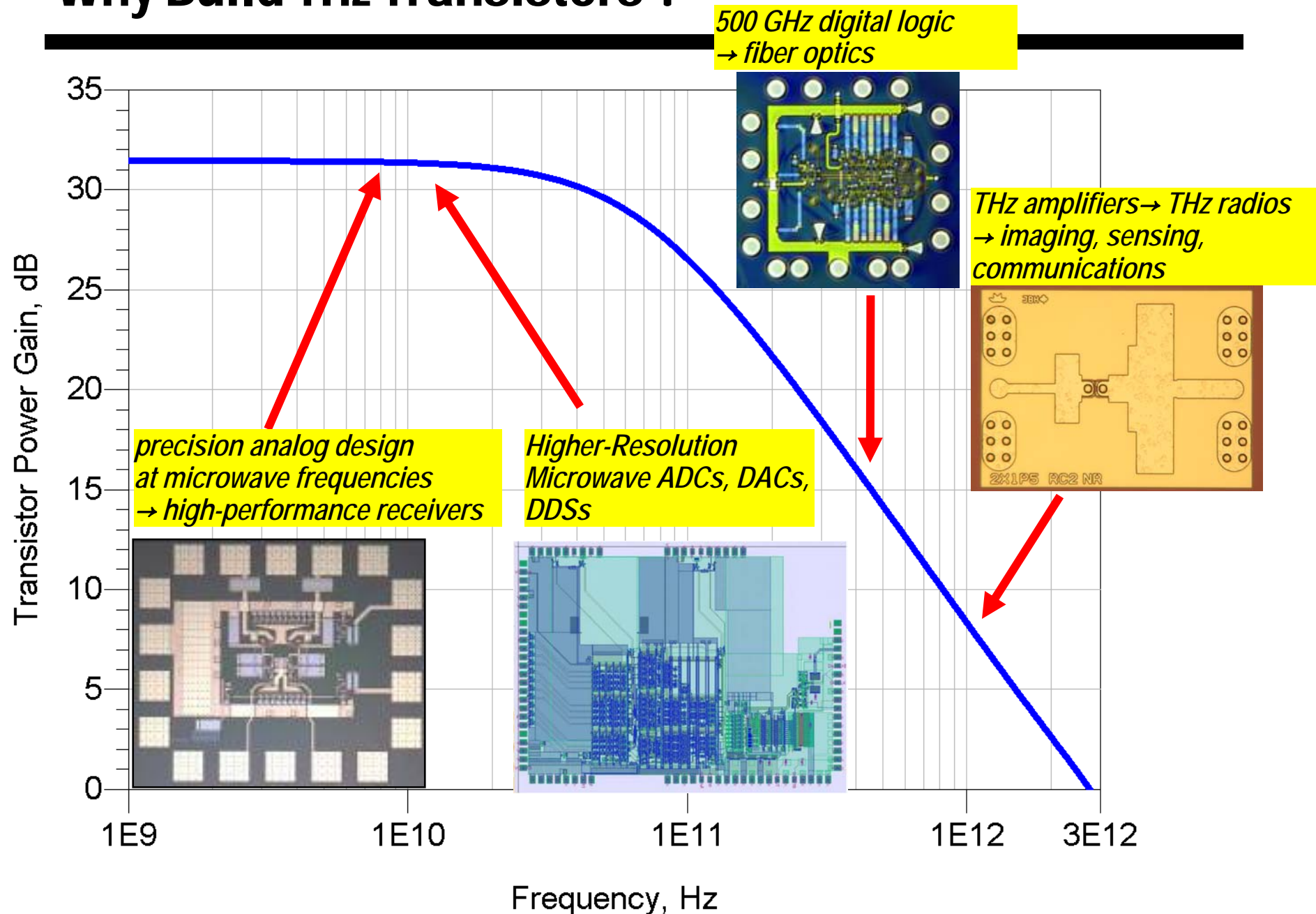
*III-V MOSFETs: help keep VLSI scaling (maybe)*

*VLSI transistors: subvert Boltzmann → solve power crisis*

*mm-wave VLSI: massively complex ICs to re-invent radio*

# Why THz Transistors ?

# Why Build THz Transistors ?



# How to Make THz Transistors

# Frequency Limits and Scaling Laws of (most) Electron Devices

$$\tau \propto \text{thickness}$$

$$C \propto \text{area} / \text{thickness}$$

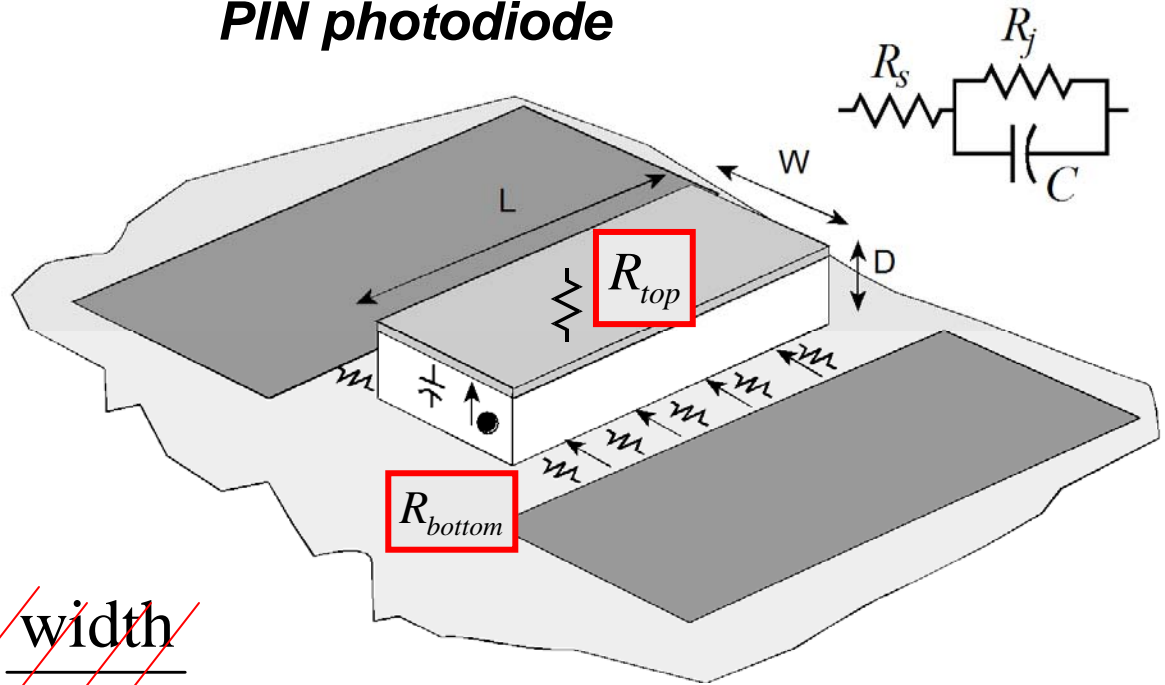
$$R_{top} \propto \rho_{contact} / \text{area}$$

$$R_{bottom} \propto \frac{\rho_{contact}}{\text{area}} + \frac{\rho_{sheet}}{4} \cdot \frac{\text{width}}{\text{length}}$$

$$I_{\text{max, space-charge-limit}} \propto \text{area} / (\text{thickness})^2$$

$$\Delta T \propto \frac{\text{power}}{\text{length}} \times \log\left(\frac{\text{length}}{\text{width}}\right)$$

*PIN photodiode*



**To double bandwidth,**

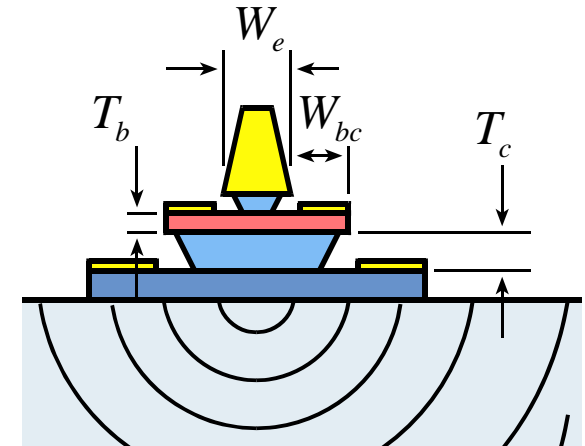
**reduce thicknesses 2:1      Improve contacts 4:1**

**reduce width 4:1, keep constant length**

**increase current density 4:1**



# Bipolar Transistor Scaling Laws



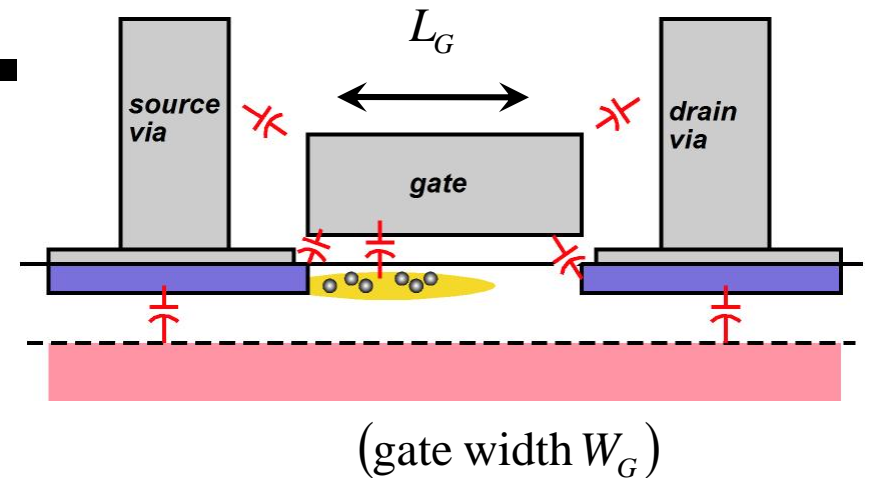
*Changes required to double transistor bandwidth:*

(emitter length  $L_E$ )

parameter	change
collector depletion layer thickness	decrease 2:1
base thickness	decrease 1.414:1
emitter junction width	decrease 4:1
collector junction width	decrease 4:1
emitter contact resistance	decrease 4:1
current density	increase 4:1
base contact resistivity	decrease 4:1

*Linewidths scale as the inverse square of bandwidth because thermal constraints dominate.*

# FET Scaling Laws



*Changes required to double transistor bandwidth:*

parameter	change
gate length	decrease 2:1
gate dielectric capacitance density	increase 2:1
gate dielectric equivalent thickness	decrease 2:1
channel electron density	increase 2:1
source & drain contact resistance	decrease 4:1
current density (mA/ $\mu\text{m}$ )	increase 2:1

***Linewidths scale as the inverse of bandwidth because fringing capacitance does not scale.***

# THz & nm Transistors: it's all about the interfaces

---

*Metal-semiconductor interfaces (Ohmic contacts):  
very low resistivity*

*Dielectric-semiconductor interfaces (Gate dielectrics):  
very high capacitance density*

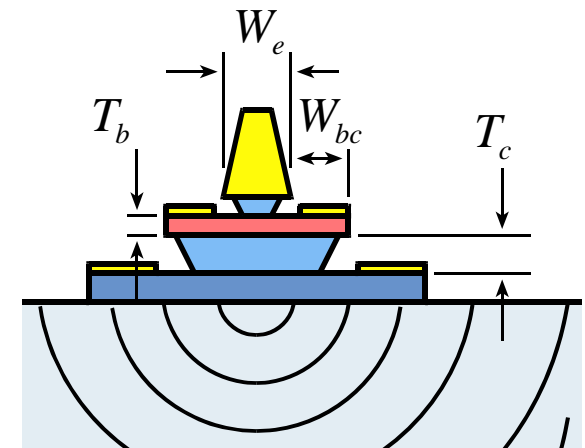
*Transistor & IC thermal resistivity.*



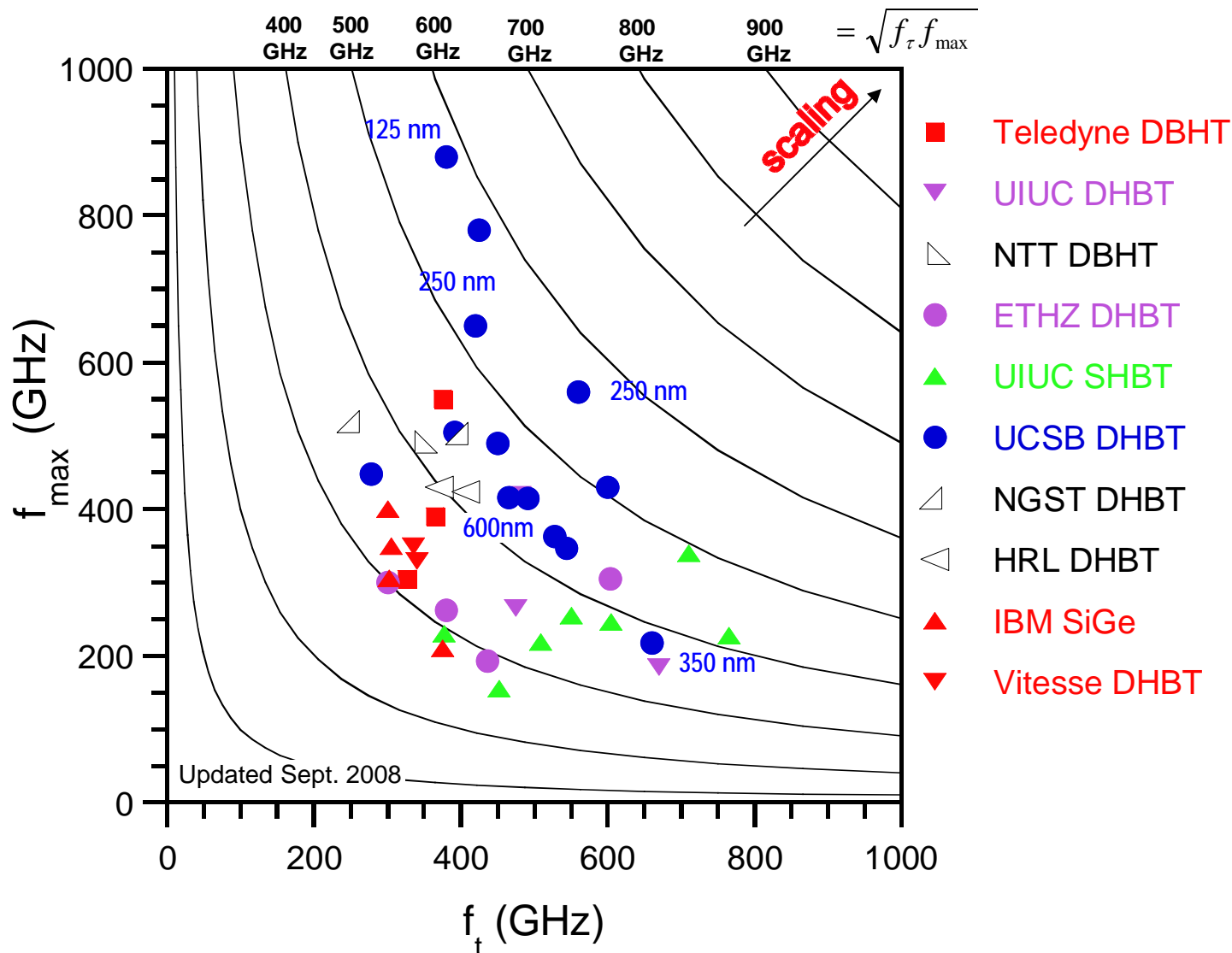
# THz Bipolar Transistors

# InP Bipolar Transistor Scaling Roadmap

	industry	university →industry	university 2007-9	appears feasible	maybe
emitter	512 16	256 8	128 4	64 2	32 nm width 1 $\Omega \cdot \mu\text{m}^2$ access $\rho$
base	300 20	175 10	120 5	60 2.5	30 nm contact width, 1.25 $\Omega \cdot \mu\text{m}^2$ contact $\rho$
collector	150 4.5 4.9	106 9 4	75 18 3.3	53 36 2.75	37.5 nm thick, 72 $\text{mA}/\mu\text{m}^2$ current density 2-2.5 V, breakdown
$f_\tau$	370	520	730	1000	1400 GHz
$f_{\text{max}}$	490	850	1300	2000	2800 GHz
power amplifiers	245	430	660	1000	1400 GHz
digital 2:1 divider	150	240	330	480	660 GHz



# InP DHBTs: September 2008



## popular metrics :

$f_{\tau}$  or  $f_{\max}$  alone

$$(f_{\tau} + f_{\max}) / 2$$

$$\sqrt{f_{\tau} f_{\max}}$$

$$(1/f_{\tau} + 1/f_{\max})^{-1}$$

## much better metrics :

### power amplifiers :

PAE, associated gain,  
mW/ $\mu$ m

### low noise amplifiers :

$F_{\min}$ , associated gain,

### digital :

$f_{\text{clock}}$ , hence

$$(C_{cb} \Delta V / I_c),$$

$$(R_{ex} I_c / \Delta V),$$

$$(R_{bb} I_c / \Delta V),$$

$$(\tau_b + \tau_c)$$

# **Ohmic Contacts Good Enough for 3 THz Transistors**

*64 nm (2.0 THz) HBT needs  $\sim 2 \Omega - \mu\text{m}^2$  contact resistivities*

*32 nm (2.8 THz) HBT needs  $\sim 1 \Omega - \mu\text{m}^2$*

## ***Contacts to N-InGaAs\*:***

<i>Mo</i>	<i>MBE in-situ</i>	<i>0.3 (+/- 0.3) <math>\Omega - \mu\text{m}^2</math></i>
<i>TiW</i>	<i>ex-situ</i>	<i><math>\sim 1</math> to <math>2 \Omega - \mu\text{m}^2</math></i>

## ***Contacts to P-InGaAs:***

<i>Mo</i>	<i>MBE in-situ</i>	<i>below <math>2.5 \Omega - \mu\text{m}^2</math></i>
<i>Pd/...</i>	<i>ex-situ</i>	<i>0.36 (+/- 0.3) <math>\Omega - \mu\text{m}^2</math></i>

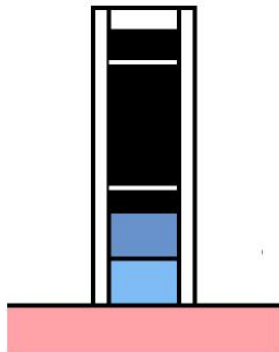
*\*measured emitter resistance remains higher than that of contacts.*

Approved For Public Release, Distribution Unlimited

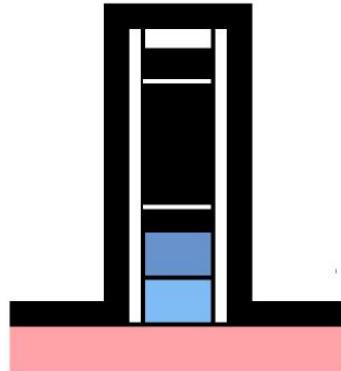


# THz HBTs: MOSFET-like Processes for 64, 32 nm Nodes

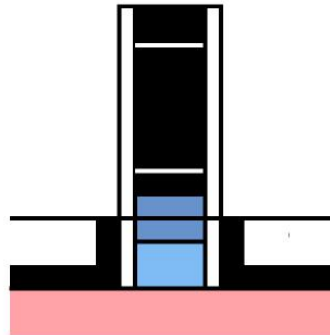
*emitter*



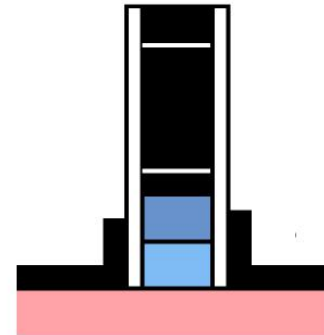
*metal*



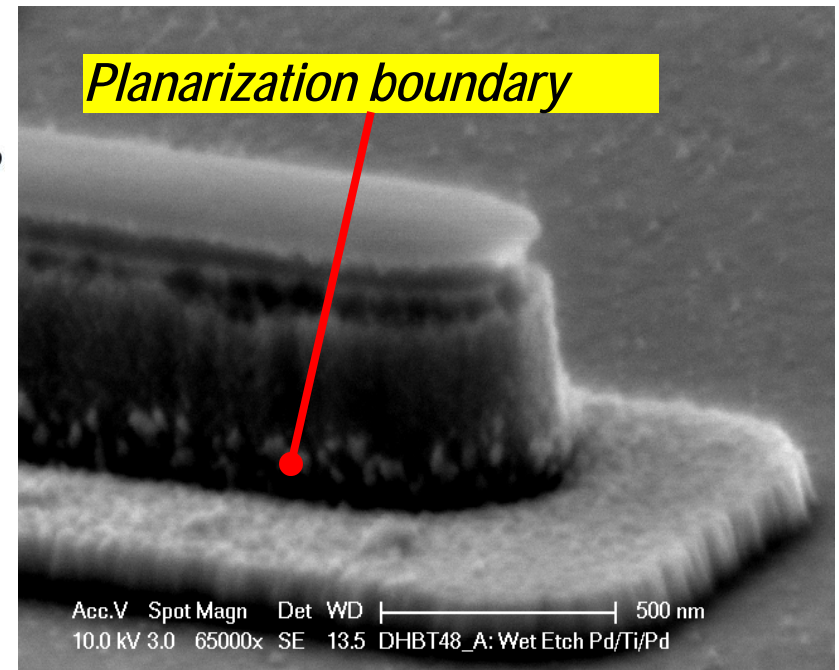
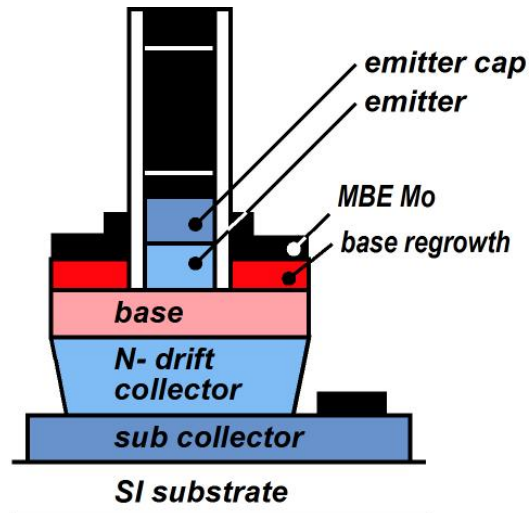
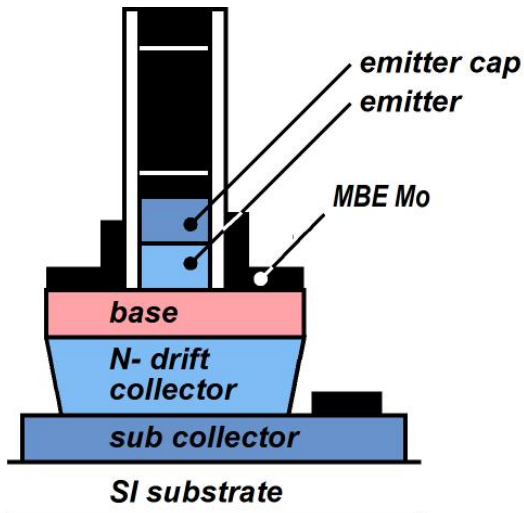
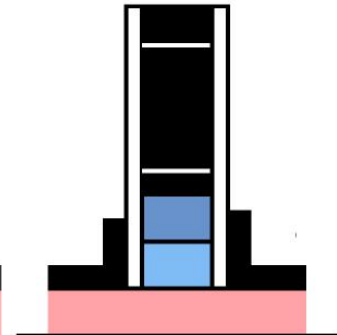
*planarize*



*etch*



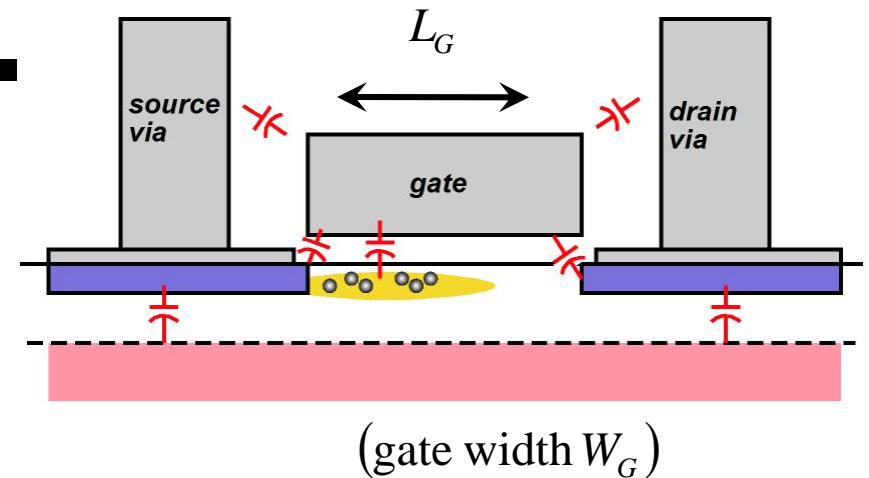
*pattern*





# nm MOSFETs

# FET Scaling Laws



*Changes required to double transistor bandwidth:*

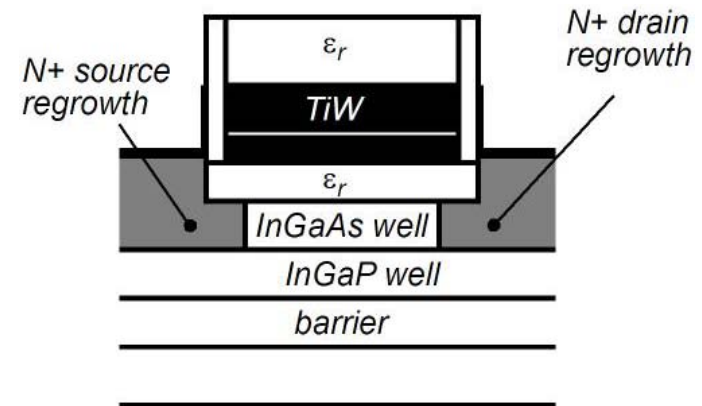
parameter	change
gate length	decrease 2:1
gate dielectric capacitance density	increase 2:1
gate dielectric equivalent thickness	decrease 2:1
channel electron density	increase 2:1
source & drain contact resistance	decrease 4:1
current density (mA/ $\mu\text{m}$ )	increase 2:1

***What do we do if gate dielectric cannot be further scaled ?***

# III-V MOSFETs for VLSI

What is it ?

*MOSFET with an InGaAs channel*

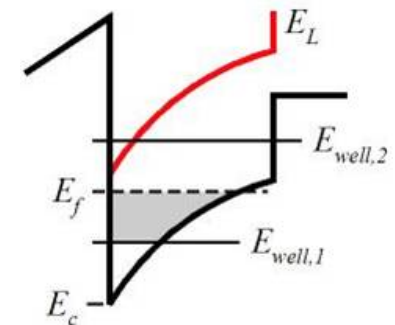


Why do it ?

*low electron effective mass  $\rightarrow$  higher electron velocity  
more current, less charge at a given insulator thickness & gate length  
very low access resistance*

What are the problems ?

*low electron effective mass  $\rightarrow$  constraints on scaling !  
must grow high-K on InGaAs, must grow InGaAs on Si*

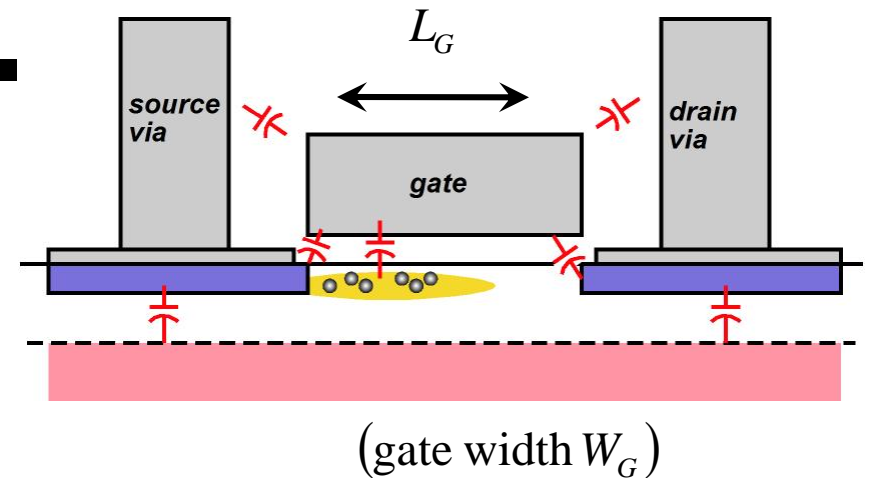


Synopsis

*III-V MOSFET might win... if Si gate dielectric cannot scale below 0.5 nm*

# THz Field-Effect Transistors (THz HEMTs)

# FET Scaling Laws



*Changes required to double transistor bandwidth:*

parameter	change
gate length	decrease 2:1
gate dielectric capacitance density	increase 2:1
gate dielectric equivalent thickness	decrease 2:1
channel electron density	increase 2:1
source & drain contact resistance	decrease 4:1
current density (mA/ $\mu\text{m}$ )	increase 2:1

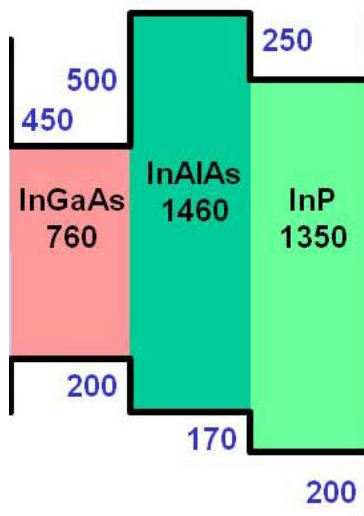
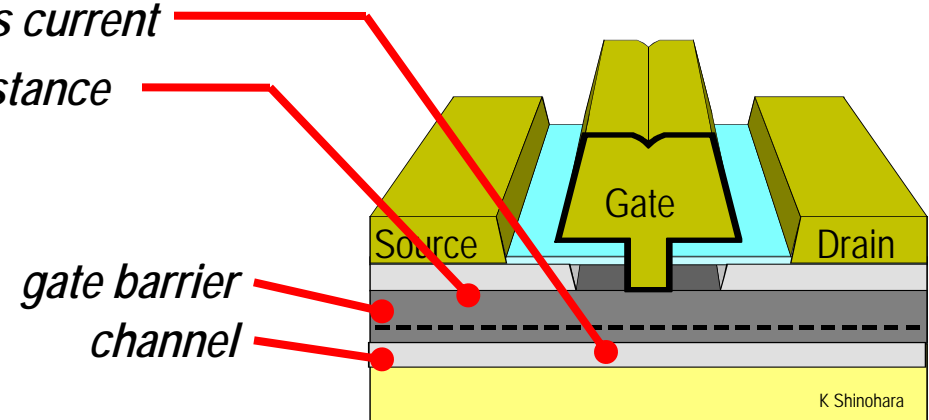
***InGaAs HEMTs are best for mm-wave low-noise receivers...  
...but there are difficulties in improving them further.***

# Why HEMTs are Hard to Improve

*1<sup>st</sup> challenge with HEMTs: reducing access resistance*

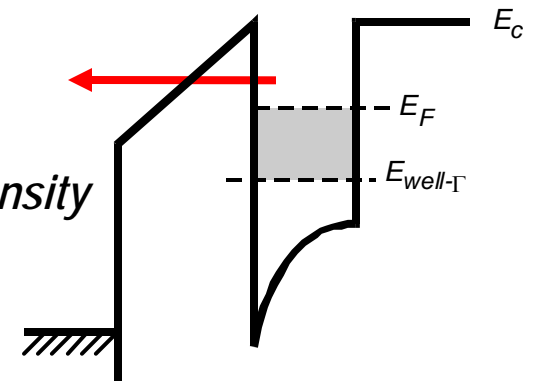
*low electron density under gate recess → limits current*

*gate barrier lies under S/D contacts → resistance*



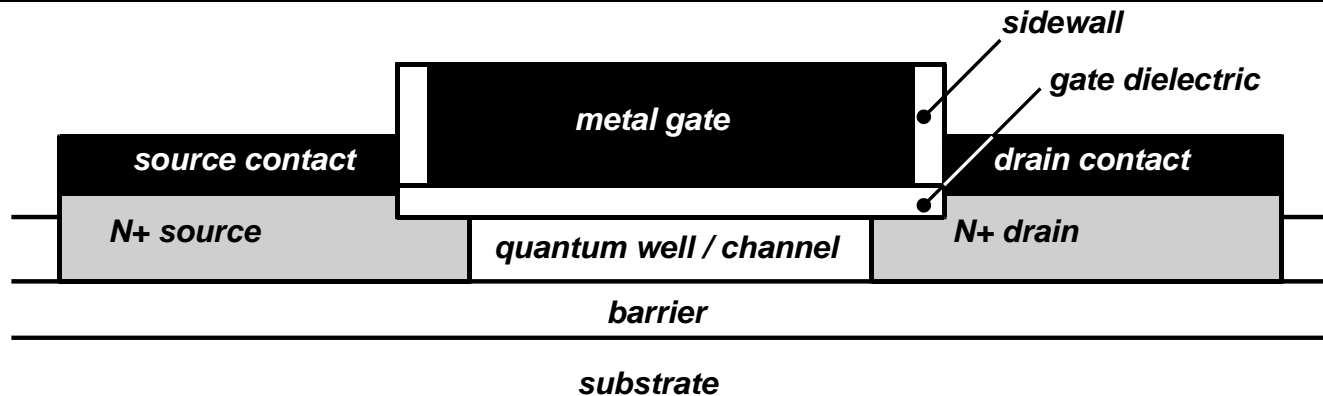
*2<sup>nd</sup> challenge with HEMTs:  
low gate barrier*

*high tunneling currents with thin barrier  
high emission currents with high electron density*



*III-V MOSFETs do not face these scaling challenges*

# InGaAs MOSFETs as THz Low-Noise Amplifiers



## Why ?

*Much lower access resistance in S/D regions*

*Higher gate barrier → higher feasible electron density in channel*

*Higher gate barrier → gate dielectric can be made thinner*

## Estimated Performance (?)

*2 THz cutoff frequencies at 32 nm gate length*

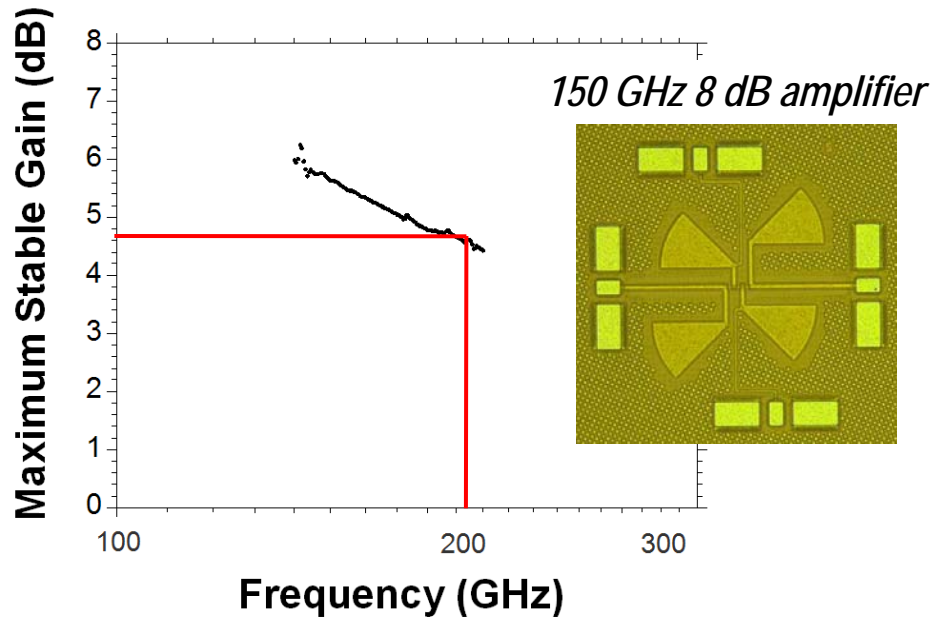
# VSLI for mm-wave & sub-mm-wave systems



# Billions of 700-GHz Transistors → Imaging & Arrays

*65 nm CMOS: ~5 dB gain @ 200 GHz*

*22 nm will be much faster yet.*



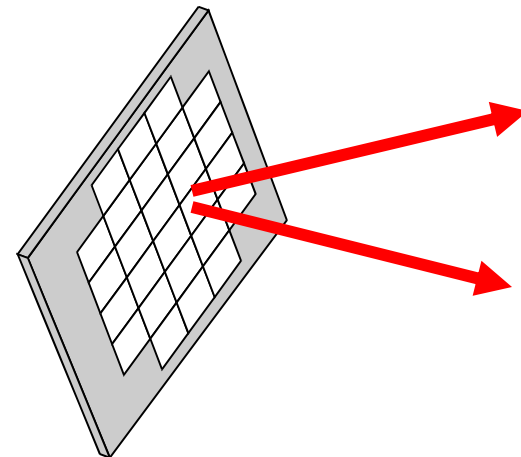
*What can you do with a few billion 700-GHz transistors ?*

*Build Transmitter / Receiver Arrays*

*100's or 1000's of transmitters or receivers*

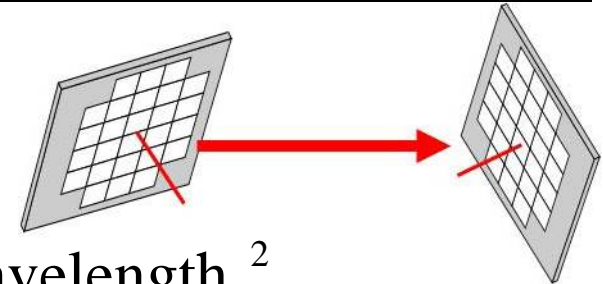
*...on < 1 cm<sup>2</sup> IC area*

*...operating at 100-500 GHz.*



# Billions of 700-GHz Transistors → Imaging & Arrays

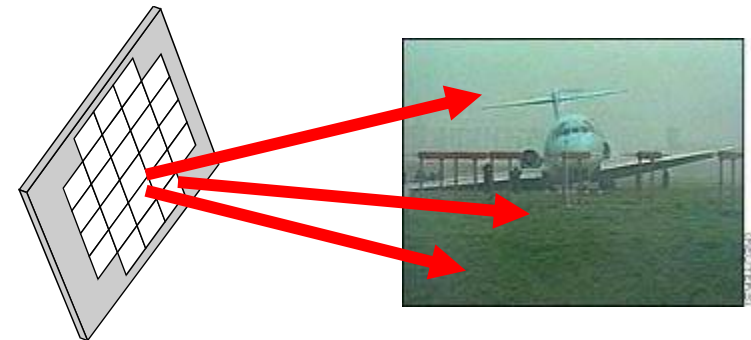
*Arrays for point-point radio links:*



$$\text{bit rate} \cdot \text{distance}^2 \propto (\# \text{ array elements})^2 \cdot \text{wavelength}^2$$

*Arrays for (sub)-mm-wave imaging :*

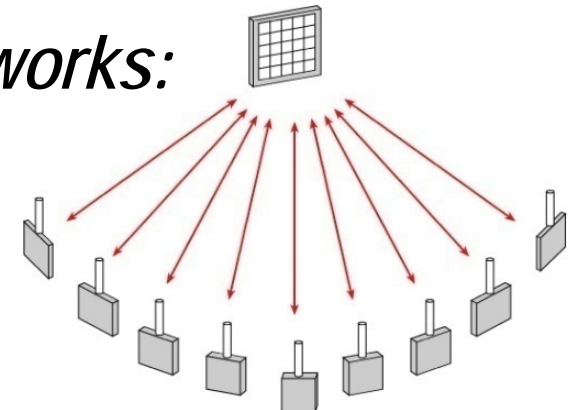
# resolvable pixels = # array elements



*Arrays for Spatial-Division-Multiplexing Networks:*

# independent beams = # array elements

$$\leq \frac{4 \cdot \text{array area}}{\text{wavelength}^2}$$



# It's a great time to be working on electronics !

---

*Device scaling (Moore's Law) is not yet over.*

*Challenges in scaling:  
contacts, dielectrics, heat*

*Multi-THz transistors:  
for systems at very high frequencies  
for better performance at moderate frequencies*

*Vast #s of THz transistors  
complex systems  
new applications.... imaging, radio, and more*

MICROSYSTEMS TECHNOLOGY OFFICE

# MTD SYMPOSIUM

The logo for the Microsystems Technology Office (MTO) Symposium. It features the letters "MTD" in a large, bold, metallic font. The "D" is stylized with a globe in the center, and the word "DARPA" is written across it. Circuit traces extend from the "M" and "D". Below "MTD" is the word "SYMPOSIUM" in a smaller, white, sans-serif font. The entire logo is set against a dark background with a reflection effect below it.

BUILDING THE FUTURE  
FROM THE INSIDE OUT

The background of the poster is a collage of various technological and infrastructure elements. On the left, there's a large satellite dish and a solar panel array. In the center, a ship's mast with various antennas and sensors is visible. On the right, there's a large, complex structure that looks like a space station or a large industrial facility. The entire background is in shades of blue and white, with a grid pattern overlaid.

Approved For Public Release, Distribution Unlimited